



INSTYTUT TECHNOLOGII ELEKTRONOWEJ

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UNIA EUROPEJSKA
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ROZWOJU REGIONALNEGO



DKZ/19/2009

Warsaw, 07.05.2009

The Institute of Electron Technology informs that the close examination of the offers submitted in the course of the open tendering procedure for the **delivery of the system for etching with use of focused ion beam (FIB)**, has led to the selection of the offer presented by FEI Europe B.V., Achtseweg Noord 5, P.O. Box 80066, 5600 KA Eindhoven, Netherlands, which was the only offer fulfilling the requirements.

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